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Effect of stochastic dead space on noise in avalanche photodiodes

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# Abstract:

A stochastic dead-space model for impact ionization is developed and used to study the effect of the soft nature of the ionization capability of carriers on the excess noise factor of avalanche photodiodes. The proposed model is based on the rationale that the gradual, or soft, transition in the probability density function (PDF) for the distance from birth to impact ionization can be viewed as that resulting from uncertainty in the dead space itself. The resulting soft PDF, which is parameterized by a tunable softness parameter, is used to establish the limitations of the existing hard-threshold ionization models in ultrathin multiplication layers. Calculations show that for a fixed operational gain and fixed average dead space, the excess noise factor tends to increase as a result of the softness in the PDF in very thin multiplication layers (viz, <70 nm), or equivalently, under high applied electric fields (viz., >800 kV/cm). A method is proposed for extracting the softness parameter from noise versus multiplication measurements.

# SECTION I. Introduction

IT HAS become evident in recent years that the excess noise factor in avalanche photodiodes (APDs) with thin multiplication layers (viz., <200 nm) is significantly lower than that originally anticipated by the McIntyre multiplication theory [1]. This is now known to be a result of the dead space, which is the minimum distance that a carrier must travel in order to acquire sufficient energy enabling it to impact ionize [2]–[3][4][5][6] [7]. Notably, the effect of dead space on the carrier multiplication process has been shown to become more pronounced as the thickness of the multiplication layer is reduced [2]–[3] [4]. As the device becomes thinner (while holding the mean gain fixed), dead space begins to occupy a larger fraction of the multiplication region and its effect on the excess noise factor becomes substantial.

Since the time when Spinelli and Lacaita [8] pointed out the significance of the dead-space effect in thin APDs, there have been many APDs developed whose noise characteristics could not be explained without considering the dead-space effect. Hu et al. [9] experimentally demonstrated the noise reduction in a thin multiplication region GaAs APD and attributed it to the “size effect” (i.e., dead-space effect). Later, Li et al. [2] demonstrated the significance of the dead space in thin multiplication layers (GaAa) and Ong et al. [10] used the dead-space analytical model to account for the noise reduction. Their results were also tested using Monte Carlo simulation, as reported in [3]. Subsequently, Yuan et al. [11] showed the effect using McIntyre's history-dependent theory [6]. At the same time, Saleh et al. [4], [5] explained the noise reduction of GaAs, AlGaAs, InAlAs, and InP APDs using the recurrence theory developed by Hayat et al. [12], [13]. Most recently, Beck et al. [14] and Ma et al. [15] demonstrated the noise-free HgCdTe APD and reasoned the noise characteristics with the dead-space effect [6]. Thus, the dead-space model is not only useful in near-infrared devices, but it also extends to midinfrared applications. In addition to noise analysis, the dead-space effect also applies to the speed analysis as shown by Ng et al. [16], Hambleton et al. [17], and Hayat et al. [18]. In addition, the dead-space model has evolved to demonstrate even lower than expected noise due to the so-called initial-energy effect and the heterojunction effect in bandgap engineered heterostructure APDs [19]–[20][21][22]. The dead-space model can be used to design and optimize such heterostructure APDs. Finally, recent studies have also shown that the dead space impacts the breakdown probability characteristics as a function of the reverse-bias voltage [23], [24].

A convenient and simple way to model the dead space is to assume that the density of impact ionization (i.e., the ionization coefficient) is zero before the dead space, after which it abruptly assumes a constant rate (namely, the ionization coefficient of enabled carriers that have reached an equilibrium energy distribution). With this assumption, Okuto and Crowell [25] developed a model to calculate the mean multiplication gain. Later, Hayat et al. [12], [13], [26] developed a recursive technique that facilitated the calculation of the excess noise factor and characterized the probability distribution of the gain. We refer to this model as the hard-threshold dead-space multiplication theory (HDSMT). In fact, the HDSMT model is the spatial analog of the fixed nonparalyzable dead-time-modified Poisson process [27]–[28] [29]; the underlying Poisson character of this process is responsible for the exponential behavior of the interevent intervals for distances greater than the dead space. Using the HDSMT and its more recent variants, good agreement with experimental measurements has been observed for multiplication-region thicknesses down to 100 nm [4], [5], [21]. From a physical viewpoint, however, one would expect the ionization density to gradually increase from zero to its constant steady-state value. Indeed, Monte Carlo simulation studies [3], [30]–[31][32] have shown a smooth rise in the ionization probability density (the ionization rate) from zero to a steady-state value, which demonstrates the soft nature of the ionization ability of carriers, as discussed in more detail below.

In some physical processes, including impact ionization, the dead space is stochastic, rather than fixed (which gives rise to the variable nonparalyzable dead-time modified Poisson process [33]). The principal cause of this randomness of the dead space in impact ionization is twofold: 1) There is uncertainty in the actual energy that a carrier must accumulate in order to reach the ionization threshold. This is due to the fact that there is uncertainty in a carriers (both injected and offspring) energy prior to ionization. For example, unlike the implicitly-adopted assumption in the HDSMT, a parent carrier may not lose all of its accumulated energy upon impact ionizing but may retain some residual energy. At the same time, an offspring carrier may be generated with nonzero energy. Moreover, Sano et al. [34] pointed out that carriers are not necessarily travelling parallel to the field direction and thus, their momenta are random. Therefore, the ionization threshold energy depends on the wave vectors of initiating carriers, and this brings about uncertainty in the ionization threshold energy itself. 2) The occurrence of phonon scattering, as the carrier travels through the high-field region, also impacts the total energy that it must accumulate as it can release or absorb energy by phonon scattering. In fact, using Monte Carlo simulation Plimmer et al. [35] have observed that the softness in the ionization ability of carriers caused by phonon scattering is more significant than that caused by uncertainty in the initial energy of carriers.

In other circumstances, carriers can be gradually, rather than abruptly, enabled to impact ionize, resulting in relative-dead space model (also called a sick-space model or a soft-threshold ionization rate model), which is the spatial analog of the sick-time-modified Poisson process [36]. In particular, once a carrier has reached the ionization threshold energy, it may ionize at a rate that depends on the energy it has in excess of the ionization threshold energy. Naturally, this effect brings about softness in the ionization rate beyond the ionization threshold energy. Despite their distinct origins, both the stochastic dead-space (SDS) effect and the relative dead-space effect result in a softness in the ionization capability of carriers.

Monte Carlo studies suggest that the effect of the softness in the ionization capability becomes significant in the analysis of very thin devices (below 100 nm) and high electric fields. For example, Ong et al. [10] showed that the noise of a 50-nm device is not accurately predicted by the HDSMT. Recently, an analytical study was undertaken by Tan et al. [37] to capture the threshold softness. They proposed a soft-threshold ionization (or a relative dead-space approach) model, which permitted the gradual increase of the ionization probability from zero to the steady-state value. Their method involved employing a shape function, taken as the indefinite integral of a Gaussian function with a width parameter *s*, which would control the smoothness of the transition of the ionization probability (a small *s* value would give a sharp transition while a large *s* value would yield a more gradual transition). Tans model was applied to a Si APD and the *s* parameter was fitted to measured excess noise data (the HDSMT model, in this case, would predict higher noise than measurement). Despite the success of Tans work in capturing the softness of the ionization capability, there are some key questions that remain unanswered. For example, as *s* increases, so does the effective dead space; thus, it is not clear whether the reduced noise suggested in Tans work is mainly a result of the softness of the ionization ability, the elongated effective dead space, or both. Intuitively, if we keep the effective dead space constant while softening the ionization ability (without changing the mean multiplication), we would expect the noise to increase, as the softness will add to the overall uncertainty of the multiplication process.

In this paper, we make use of the SDS approach to capture the softness in the ionization capability of carriers and study its effect on the excess noise factor. In particular, our intent is to perform a systematic study to show at which thicknesses the accuracy of the HDSMT model becomes questionable. We perform this by systematically introducing uncertainty in the dead space, which successfully resulted in various degrees of softness in the ionization probability. The approach is based on randomizing the dead space in the HDSMT model, which results in a soft probability density function (PDF) for the distance from the carriers birth to impact ionization. This soft PDF contains a tunable parameter governing the variability range of the dead space, which in turn, controls the degree of softness in the ionization ability of carriers. In comparison to the relative dead-space (sick-space) model, this approach obviates the need for postulating an ad hoc recovery function for the sick space while providing an adequate representation of the softness in the ionization capability of carriers.

# SECTION II. SDS Model

As stated earlier, we will regard the dead space as a random variable, which is used, in turn, in a randomized version of the HDSMT model to obtain a PDF of the ionization distance. Consider a multiplication region extending from *x*=0 to *x*=*w*, and let *De*(*x*) denote the random dead space for an electron born at location *x*. Now suppose that *δ* is a particular realization of the random dead space *De*(*x*). Then, conditional on *De*(*x*)=*δ* and according to the HDSMT, the PDF of the location *ξ* (measured relative to *x*=0) at which the electron impact ionizes has the shifted-exponential form given by [12], [20]

(1)

where it is understood that *δ* is a particular realization of the random dead space. Here, *α*(*x*) is the nonlocalized ionization coefficient for the electron, that is, the ionization coefficient for electrons that have already travelled the dead space. This ionization coefficient is assumed to be position dependent through its dependence on the nonuniform electric field.

Next, we will ensemble average the above conditional PDF, given by [(1)](https://ieeexplore.ieee.org/document/#deqn1), over all possible realizations of the random dead space and obtain the unconditional PDF (with the dead-space averaged) given by

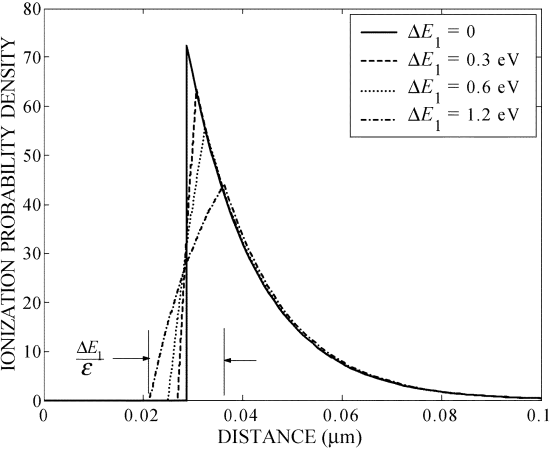
(2)

where the expectation operator“E” is taken with respect to the PDF of the random dead space *De*(*x*), which is denoted in [(2)](https://ieeexplore.ieee.org/document/#deqn2) by *fDe*(*x*)(⋅). In the case of a spatially uniform nonlocalized ionization coefficient *α*, [(2)](https://ieeexplore.ieee.org/document/#deqn2) can be determined with the knowledge of the PDF of the dead space. For simplicity, if we assume that *De*(*x*) is uniformly distributed in the interval [*d*min,*d*max], then calculations yield

(3)

where .

Let us now examine the key properties of the above PDF, as shown in Fig. 1. First, the PDF is zero when *ξ*<*x*+*d*min. Second, the point *ξ*=*x*+*d*min is where the PDF starts to rise and *ξ*=*x*+*d*max is the point where the PDF reaches its peak value; and third, for *ξ*>*x*+*d*max, the PDF decays exponentially at a rate *α*. Thus, we have arrived at a PDF that exhibits a soft ionization capability, where the peak value is gradually attained over a distance Δ*d* beyond a minimal-dead-space point where the PDF begins to ascend from 0. Clearly, when Δ*d*=0, in which case the dead space is deterministic, the PDF in [(3)](https://ieeexplore.ieee.org/document/#deqn3) collapses to the HDSMT PDF, as given by [(1)](https://ieeexplore.ieee.org/document/#deqn1). Note that the dead-space uncertainty Δ*d* can be interpreted as uncertainty in the energy, Δ*E*, needed to be acquired from the field in order to achieve the ionization threshold energy: Δ*E*=*q*EΔ*d*, where *q* is the electronic charge and E is the applied electric field. We call the PDF of the form shown in Fig. 1 a *soft* PDF, and parameter Δ*E* is termed the *softness parameter*, as it controls the softness in the transition from zero to the peak value of the soft PDF. It is important to point out that the choice of a uniform distribution for the dead space ultimately affects the shape of the soft PDF, and in particular, it is responsible for its sharp peak at the designated ionization distance. Conceivably, we would expect that if a more realistic distribution is used, the sharpness of the peak will be reduced yielding a theoretical PDF which better resembles that obtained from Monte Carlo simulations [10], [35]. The choice of a uniform distribution, in this case, resulted from our insufficient analytical knowledge of the true distribution of the dead space. This distribution, nonetheless, captures the dead-space randomness using a minimum number of unknown parameters (namely, Δ*E*).

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**Fig. 1.** Soft probability density function of the ionization distance. The average dead space is assumed fixed and the softness parameter Δ*E*1 is varied. The arrows indicate the degree of softness introduced in the PDF as a result of Δ*E*1=1.2 eV.

In the next section we will use the average distance between ionization events, ⟨*l*⟩, in the calculation of the ionization rates to be used in conjunction with the soft PDF [(3)](https://ieeexplore.ieee.org/document/#deqn3). The average interionization distance is

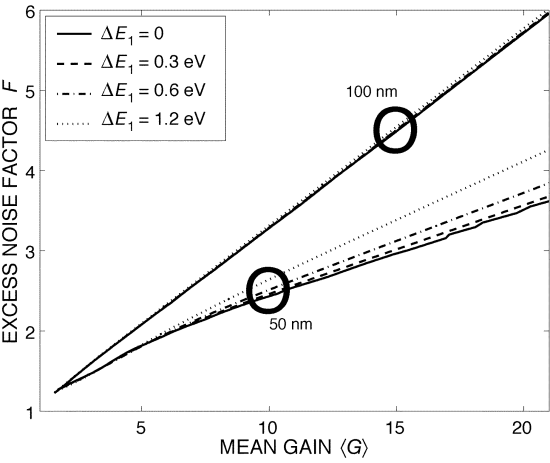
(4)

and in the case of a uniform electric field, ⟨*l*⟩ turns out to be

(5)

With the soft PDF [(3)](https://ieeexplore.ieee.org/document/#deqn3) at hand, we proceed to study the effect of the stochastic dead space on the excess noise factor in thin APDs.

# SECTION III. Results and Discussion

[[](https://ieeexplore.ieee.org/mediastore_new/IEEE/content/media/16/28966/1303826/1303826-fig-2-source-large.gif)](https://ieeexplore.ieee.org/mediastore_new/IEEE/content/media/16/28966/1303826/1303826-fig-2-source-large.gif)

**Fig. 2.** Predicted excess noise factor *F* versus the mean gain ⟨*G*⟩ for a 100-nm GaAs APD using the SDS model. The parameter Δ*E*1 is varied while the average dead space is held fixed.

The impact of the SDS model on the excess noise factor can be studied by observing the effect of varying the softness parameter in the soft PDF while fixing the average dead space. This observation aims to characterize the sensitivity of the recursive technique for computing the excess noise factor [26] to the stochastic nature of the dead space (viz., the dead-space range Δ*d*, or equivalently Δ*E*). In particular, we will establish range of the multiplication-region width over which incorporating the stochastic dead space would be important. Then, we will conform the SDS model to a physical setting where we fix the minimum dead space (corresponding to a minimal theoretical ionization threshold) and introduce an appropriate range for the dead-space uncertainty. This would provide a method for extracting the softness parameter from the APDs noise-versus-gain data in a realistic setting for which the dead space is assumed to be random in an unknown range but with a known lower bound.

### A. Sensitivity of the Excess Noise Factor to Dead Space Uncertainty

Here, we keep the average dead space in the SDS model fixed and gradually vary the uncertainty Δ*d* about it through varying Δ*E*. This will restrict our attention to the effect of the dead-space uncertainty without altering the average length of the dead space. We use the average dead spaces, ⟨*De*⟩=*d*¯*e* and ⟨*Dh*⟩=*d*¯*h*, which are computed from the effective ionization threshold energies of 2.3 eV for electrons and 2.1 eV for holes, as reported in [10]. We used the Monte Carlo simulation results reported in [10] to obtain the effective ionization coefficients *αMC* and *βMC*, for the electrons and holes, respectively. Since the average ionization length is simply the reciprocal of the ionization coefficients obtained from the Monte Carlo simulation, we set ⟨*le*⟩=*α*−1*MC* and ⟨*lh*⟩=*β*−1*MC* and find the nonlocalized ionization coefficients *α* and *β* which are to be used in the SDS model given in [(3)](https://ieeexplore.ieee.org/document/#deqn3). This technique for finding the nonlocalized coefficients was first introduced (to the best of our knowledge) by Spinelli and Lacaita [8] and yields the following simple formulas:

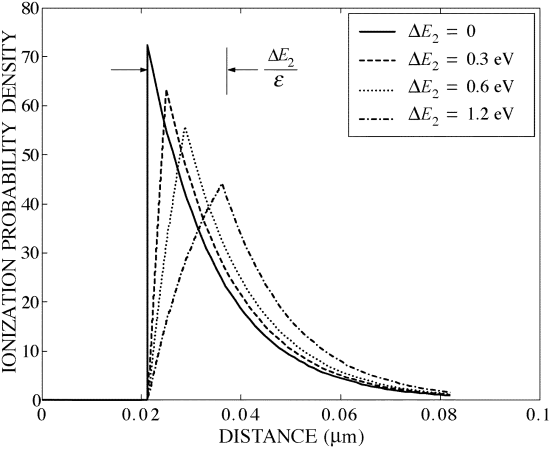
(6)

and

(7)

View SourceRight-click on figure for MathML and additional features.The soft PDFs of the impact ionization distance computed using [(3)](https://ieeexplore.ieee.org/document/#deqn3) with *x*=0 and an applied electric field of 800 kV/cm are shown in Fig. 1 for Δ*E*1=0, 0.3, 0.6, and 1.2 eV. (The subscript in Δ*E*1 is used to distinguish the case of variation about the mean from the case of variation Δ*E*2 beyond the minimal ionization energy, which will be considered in Section III-B.)

Estimates of the excess noise factor are shown in Fig. 2, which were generated using Hayat's recursive technique [26]. It is seen from the figure that the noise characteristics for a 100-nm GaAs APD is nearly insensitive to variation in the softness parameter Δ*E*1. The result indicates that for this multiplication-region width, the added softness does not affect the noise characteristics as long as the mean dead space is held fixed. In contrast, for a 50-nm multiplication region, the excess noise increases substantially as the softness is introduced. (In fact, this effect starts to become significant when the width begins to drop below 70 nm). This is in agreement with our intuition in that the stochastic nature of the dead space brings about an additional source of randomness in the avalanche multiplication process (which tends to de-emphasize the localization brought about by the dead-space phenomenon), which, in turn, would degrade the noise characteristics. We also studied significance of the degree of softness by computing the excess noise factor as a function of the multiplication region width for two cases corresponding to the hard-threshold dead-space case (i.e., Δ*E*1=0), which is used as a reference, and a maximal SDS case (corresponding to Δ*E*1=1.2 eV). The gain was held constant at 20. We found that the stochastic dead space did not significantly alter the noise prediction of a 100-nm APD (a mere 1% increase). In contrast, the noise estimate increased by more than 5% for a 70-nm APD and by approximately 18% for a 50-nm APD. Indeed, this agrees with our expectation since as the thickness of the multiplication region decreases, the uncertainty in the dead space occupies a larger fraction of the multiplication region and its impact on the excess noise factor becomes more significant. The results here are also in qualitative agreement with the Monte Carlo studies reported by Ong et al. [10], which concluded that the noise of the softness-threshold model is greater than the noise of the hard-threshold model for thin devices.

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**Fig. 3.** Soft probability density function of the ionization distance assuming a fixed minimum dead space while the softness parameter Δ*E*2 is varied. Note that in contrast to Fig. 1, the average dead space increases as Δ*E*2 increases. The arrow indicates the degree of softness introduced in the PDF as a result of Δ*E*2=1.2 eV. Note the dead space is elongated by Δ*E*2/2*q*E beyond the minimum dead space.

### B. Application to Experimental Data

Next, we employ the form of the SDS PDF [(3)](https://ieeexplore.ieee.org/document/#deqn3) but set the minimum dead space *d*min according to the minimum possible theoretical threshold energy, *E*th,min. The minimum dead spaces, *d*e,min and *d*h,min, for electrons and for holes, respectively, are obtained from the minimum ionization threshold energies, which are 1.7 eV for electrons and 1.4 eV for holes [38]. We then select the softness parameter Δ*E*2 that yields a good match with experimental results. Clearly, introducing variability in the dead space, beyond the minimum dead space, will elongate the average dead space. Thus, in this setting we introduce the precise dead-space variability, beyond a physically minimum dead space, that would render the correct excess-noise prediction. As before, the nonlocalized ionization coefficients, *α* and *β*, for the soft PDF can be found by equating the average ionization distance to the reciprocal of the effective ionization coefficients obtained by Monte Carlo simulation [10]. This yields the following formulas:

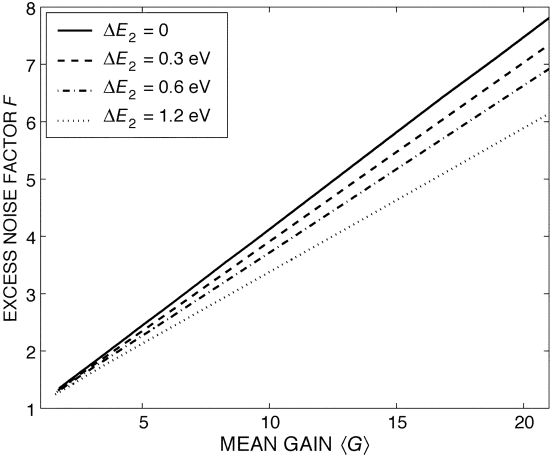
(8)

and

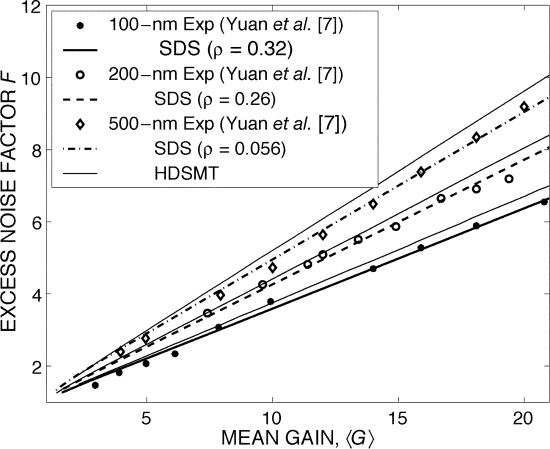
(9)

Thus, for every degree of softness in the dead space, there is a corresponding nonlocalized SDS ionization coefficient.

The PDF of the impact ionization distance for electrons is shown in Fig. 3. We emphasize that the ionization thresholds here are different from that shown earlier in Fig. 1. (Here, each ionization threshold corresponds to *E*th=*E*th,min+Δ*E*2/2, where the softness parameter Δ*E*2 is allowed to vary, whereas in Fig. 1, *E*th is fixed at the effective ionization threshold energy provided by [5].) As Δ*E*2 increases, the location where the PDF reaches its maximum moves away from the minimal dead space, representing the increase of the softness as well as the mean dead space. These PDFs are used, in turn, to compute the excess noise factor according to the recursive technique [26]. Generally, our computations show that the excess noise factor is reduced as Δ*E*2 increases, as shown in Fig. 4. This is primarily due to the fact that when the softness is introduced, the average dead space is also extended, which tends to reduce the excess noise factor and dominate the opposite noise increase accompanying the increase in the softness parameter (the effect that was demonstrated in Section III-A). Thus, the excess noise factor is reduced overall. This observation is similar in nature to that obtained by Tan et al. in which a soft-threshold model (relative dead space model) was employed [37]. Note that Δ*E*2=1.2 eV produces an equivalent soft-threshold PDF (and thus identical noise characteristics) to that corresponding to the case Δ*E*1=1.2 (shown in Figs. 1 and 2).

[[](https://ieeexplore.ieee.org/mediastore_new/IEEE/content/media/16/28966/1303826/1303826-fig-4-source-large.gif)](https://ieeexplore.ieee.org/mediastore_new/IEEE/content/media/16/28966/1303826/1303826-fig-4-source-large.gif)

**Fig. 4.** Predicted excess noise factor, *F*, versus the mean gain, ⟨*G*⟩, of a 100-nm GaAs APD. The curves are parameterized by the softness parameter Δ*E*2 but the minimum dead space is fixed at a minimum value of *E*th,min/2*q*E.

[[](https://ieeexplore.ieee.org/mediastore_new/IEEE/content/media/16/28966/1303826/1303826-fig-5-source-large.gif)](https://ieeexplore.ieee.org/mediastore_new/IEEE/content/media/16/28966/1303826/1303826-fig-5-source-large.gif)

**Fig. 5.** Comparisons between the experimental measurements of the excess noise factor *F* (obtained from Yuan et al. [7]) and the corresponding predictions of the SDS model. In the SDS model, the parameter Δ*E*2 (or *ρ*) is selected so that the computed noise-versus-gain predictions best fit the data. For comparison, the thin solid curves represent the HDSMT predictions of the excess noise factor for each device.

The fitting of the SDS model to experimental data is considered next.

#### 1. Extraction of the Softness Parameter

We will investigate the values of Δ*E*2 that show good agreement with the experimental noise-versus-gain measurements. Also, to have a better feel for the relative significance of the fitted Δ*E*2 and its dependence on the multiplication-region width, we introduce the field-independent, normalized dead-space variability parameter, *ρ*, defined as

(10)

The results are shown in Fig. 5 for 100-, 200-, and 500-nm GaAs APDs. In these computations, the minimum ionization threshold energies of 1.7 eV for electrons and 1.4 eV for holes are applied according to [38]. For the 100-nm GaAs APD, the SDS model with Δ*E*2=0.8 eV (*ρ*=0.32) shows good agreement with experiment. For the 200-nm GaAs APD, Δ*E*2=0.6 eV (*ρ*=0.26) is required, and for the 500-nm GaAs APD, Δ*E*2=0.1 eV (*ρ*=0.056). Thus, our calculations indicate that the required relative variability in the dead space, represented by the steady increase in the *ρ* parameter as the width decreases, becomes more significant as the applied electric field increases, which is consistent with the results of Monte Carlo simulations [3], [10], [31]. Although we were able to empirically estimate the softness parameter from data fitting, no theoretical expression is available at the present time which would estimate its magnitude for a specific material as a function of the applied electric field.

For comparison, the thin curves in Fig. 5 represent the noise predictions using the HDSMT. It should be noted that the parameters of the HDSMT model reported in [5] (the effective ionization thresholds, in particular) are obtained by fitting the HDSMT model to noise-versus-gain data. Thus, the HDSMT effectively incorporates the dead-space softness by generating an effective average dead space (corresponding to the effective, or dead-space inclusive, ionization threshold energies). This is why the HDSMT models work reasonably well as long as the multiplication-region width falls within the range of devices whose data were used in generating the HDSMT model parameters. However, its accuracy is questionable when the multiplication-region width is further lowered primarily because it does not explicitly capture the ionization-capability softness phenomena and the fact that the thinnest APD used in its model parameter fitting had a 100-nm multiplication region [4], [5]. The SDS model, on the other hand, has a tunable parameter Δ*E* that allows capturing the softness in the ionization capability, thus naturally providing an improved estimate of the noise at the slight expense of model complexity.

# SECTION IV. Conclusion

We have examined the noise–gain characteristics of an APD in which the impact ionization is characterized by a soft PDF, with variable softness. This PDF is obtained using a model in which the dead space is taken to be random. The outcome is a gradual transition of the ionization PDF from zero to a peak value followed by an exponential tail. The tail is associated with an ionization coefficient for enabled carriers, i.e., carriers that have reached an equilibrium energy distribution in the electric field and scattering environment. In effect, therefore, this paper studies the effect of different PDF shapes on the excess noise factor versus gain characteristics of APDs. Though the shape of the PDF is significant in the calculations, the physical origin of the shape is not. The calculations which we carried out make use of a doubly stochastic approach, i.e., a fixed dead space model in which there is an underlying stochasticity of the dead space itself. The result is a soft PDF. Were the same soft PDF profile generated by different underlying physics, resulting from an alternative stochastic phenomenon, the recurrence model would nonetheless remain unchanged and identical performance would obtain.

Our calculations of the noise show that if the average dead space is held fixed, the uncertainty in the dead space does not significantly alter the excess noise predictions unless the multiplication region width is ultrathin (viz., <70 nm). Thus, for APDs with multiplication-region widths as low as 100 nm, the commonly used hard-threshold dead space models provide adequate accuracy since incorporating the stochastic dead space does not change the predictions significantly.

In ultra-thin APDs, on the other hand, the softness of the dead space tends to increase the excess noise factor as the dead space uncertainty counteracts the orderliness that the hard-threshold dead space normally brings about. We have also developed a method for extracting the softness parameter based on noise versus gain data to illustrate the behavior of the noise characteristics as the softness is introduced. The method relies on setting the minimal dead space and selecting the dead space uncertainty range that generates the correct noise prediction. It was found that the dead-space uncertainty, normalized by the average dead space, increases as the devices become thinner, which would result in a more significant impact on the noise. That is, the model confirms that the phenomenon of the soft ionization capability becomes significant only at high fields.[15]

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